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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Vishwanathan et al.

Application No.: 09/608,537

Filed: June 30, 2000

Title: POLISHING PADS FOR CHEMICAL
MECHANICAL PLANARIZATION

Group Art Unit:

Examiner: M. Guerrero

Attorney Docket No.: 126

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TC 2800 MAIL ROOM

Assistant Commissioner for Patents
Washington, D.C. 20231

AMENDMENT AND ELECTION

Sir:

✓
Please amend the application as follows: Cancel claims 30-46 subject to refiling in a
divisional application in response to a requirement for restriction.

REMARKS

Election is made hereby to prosecute the invention of Group I, with claims 1-29, and 47-
52 readable thereon. The requirement for restriction is traversed hereby, because the apparatus
claims and method claims capable of practice by the apparatus are based on the same disclosure
and the same field of search by the USPTO, and in the interest of patent law harmonization, the
USPTO should not stand alone for requiring different patents for such patent claims.

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Typed Name: Barbara A. Wiley

Signature: Barbara A. Wiley

Respectfully submitted,
Arun Vishwanathan et al.

By Gerald K. Kita
Gerald K. Kita
Attorney/Agent for Applicant(s)
Reg. No. 24125

Date: December 10, 2001

Telephone No.: 302-366-0500